10/549933 JC17 Rec'd PCT/PTO 20 SEP 2005

Docket No.: 2342-0143PUS1

(PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Naoharu NAKAISO

Application No.: NEW

Confirmation No.: N/A

Filed: September 20, 2005

Art Unit: N/A

For:

SUBSTRATE PROCESSING APPARATUS

AND SEMICONDUCTOR DEVICE

PRODUCING METHOD

Examiner: Not Yet Assigned

## **INFORMATION DISCLOSURE STATEMENT (IDS)**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement accompanies the new patent application submitted herewith.

Copies of the references on the PTO/SB/08 are not provided.

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In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to our Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. § 1.16 or under § 1.17; particularly, extension of time fees.

Dated: September 20, 2005

Respectfully submitted

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PTO/SB/08a/b (07-05)
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Sub	stitute for form 1449A/B/PT	0		Complete if Known		
•				Application Number	10/549933	
IN	<b>IFORMATION</b>	I DI	SCLOSURE	Filing Date	September 20, 2005	
STATEMENT BY APPLICANT (Use as many sheets as necessary)				First Named Inventor	Naoharu NAKAISO	
				Art Unit	N/A	
				Examiner Name	Not Yet Assigned	
Sheet	1	of	1	Attorney Docket Number	2342-0143PUS1	

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.1	Document Number  Number-Kind Code <sup>2</sup> ( <i>if known</i> )	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear

FOREIGN PATENT DOCUMENTS						
Examiner	Cite No.1	Foreign Patent Document	Publication	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
Initials*		Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)	Date MM-DD-YYYY			T <sup>6</sup>
	ВА	JP-2002-353211-A	12-06-2002			
	BB	JP-9-102463-A	04-15-1997		•	
	ВС	JP-2003-45811-A	02-14-2003			
	BD	JP-2003-45864-A	02-14-2003			
	BE	JP-2004-134466-A	04-30-2004			

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